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Saturable Absorption with CNT Coupled WGM and Fabrication of Er-doped Microresonator for On-chip Mode-locked Laser

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Outline

- Background & Objective
- Numerical model
- Saturable absorption of CNT
- Er-doped microresonator
- Summary

Background: mode-locked laser



[3] Sze Y. Set, IEEE J. Sel. Top. Quantum Electron., 10, 1, 137-146 (2004)

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Background: mode-locked fiber ring system



Realizing this system with microcavitycavity length: 13.3 m: 13.3 m> 200 μ m: repetition rate: 15 MHz > 1000 GHz

F. Wang, et al., Nat. Nanotechnol., 3, 738-743 (2008)

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Objective:

Mode-locked laser with microresonator

- high repetition rate (> GHz)
- small footprint
- on-chip integrability ightarrow



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1. Passive mode-locker **CNT**(saturable absorber)

Erbium ions

Numerical model

Model: Nonlinear Schrödinger equation





Saturable absorption of CNT

Optical deposition on fiber microtip



output

- By using optical deposited fiber tip, saturable absorption was observed

 By changing the gap distance between microtip and tapered fiber, the absorption can be controlled.

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rption was observed d tapered fiber, the absorption



Er-doped microresonator: Process flow







Er-doped microresonator: Process flow







Er-doped microresonator: Fabrication result

The thickness of sol-gel film is $\sim 1.8 \,\mu m$ with 6 layers ($\sim 300 \,nm/layer$).



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undercutting silicon pillar



forming toroidal rim











Er-doped microresonator: Measurement



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Objective:

On-chip mode-locked laser with CNT and Er-doped microresonator

Achievement:

- Saturable absorption of CNT
 - SA is obtained by using microtip
- Er-doped microresonator
 - Fabrication of Er-doped microtoroid ____
 - Lasing at ~ 1580 nm

Future plan:

- Measuring gain (g_0) of Er-doped microtoroid
- Integration of CNT and Er-doped microtoroid

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